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APPLICANTS Kozo Nakamura, Kanagawa, JAPAN; Toshiaki Saishoji, Kanagawa, JAPAN; Hirotaka Nakajima, Kanagawa, JAPAN; Shinya Sadohara, Kanagawa, JAPAN; Masashi Nishimura, Kanagawa, JAPAN; Toshirou Kotooka, Nagasaki, JAPAN; Yoshiyuki Shimanuki, Kanagawa, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP99/06477 11/19/1999 M)				
** FOREIGN APPLICATIONS ***** JAPAN 10/330713 11/20/1998 JAPAN 11/77166 03/23/1999 M) JAPAN 11/129957 05/11/1999				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <u>M. J.</u> M)		STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 23
INDEPENDENT CLAIMS 15				
ADDRESS 24628				
TITLE Production method for silicon single crystal and production device for single crystal ingot, and heat treating method for silicon single crystal wafer				
FILING FEE RECEIVED 1874	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	